

In re Application of:  
Wai-Fan Yau, et al.

**For: A Low Dielectric Constant  
Film Produced from Silicon  
Compounds Comprising  
Silicon-Carbon Bond**

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**Examiner: Julio J. Maldonado**

## CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Julio J. Maldonado, on the date shown below.

10/23/07  
Date

**Keith M. Tackett**

**RESPONSE TO FINAL OFFICE ACTION DATED SEPTEMBER 25, 2007**

In response to the Final Office Action dated September 25, 2007, having a shortened statutory period for response set to expire on December 25, 2007, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/002592.C7/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 4 of this paper.